

Corres. and Mail
BOX AF

YU
AI
C/S

Docket No.: 060188-0751

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of

Yoshiharu HIDAKA, et al.

Application No.: 10/754,518

Filed: January 12, 2004

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

: Customer Number: 20277

: Confirmation Number: 8259

: Group Art Unit: 2814

: Examiner: Thao X. Le

For: SEMICONDUCTOR SUBSTRATE, METHOD FOR FABRICATING THE SAME, AND
METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

REQUEST FOR RECONSIDERATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated October 7, 2005, having a three-month shortened statutory period for response set to expire on January 7, 2006 (Saturday), reconsideration of the above-identified application is respectfully requested in view of the following remarks.